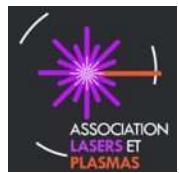




PETAL-UPgrade

Emmanuel HUGONNOT – CEA Cesta





The PETAL UPgrade project



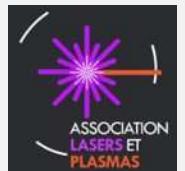
- aims to improve performances of
- is co-funded by
- has been launched in **07/2021**



The goal is to improve PETAL laser performances

- adjustable temporal contrast**
- 1 kJ pulse energy**
- two beams delivery on target**

*Wishes of the community
gathered at the 1st LMJ-
PETAL user meeting (2018)*



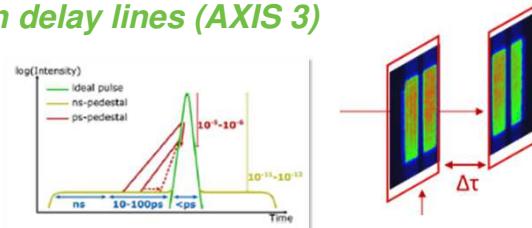
*and to possibly add a **B-field capability** on the LMJ-PETAL experiment subsystem*

Four axis



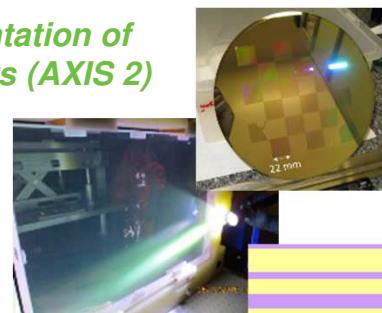
AXIS 1: Control of temporal contrast on target

New front-end with adjustable temporal contrast (AXIS 1) and beam splitting with delay lines (AXIS 3)



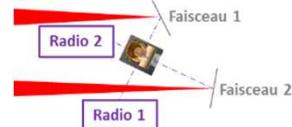
AXIS 2: Increase of energy on target

Implementation of new mirrors (AXIS 2)



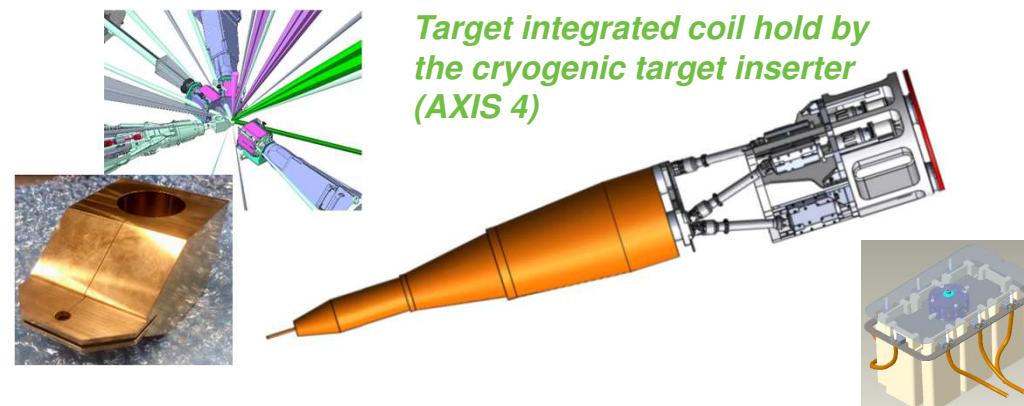
V4 = design optimisé
 $(HL)^x i_1 H i_2 L i_3 H \dots i_s H$

AXIS 3: Adaptation to the production of two beams



AXIS 4: Implementation of experiments in the presence of a strong magnetic field

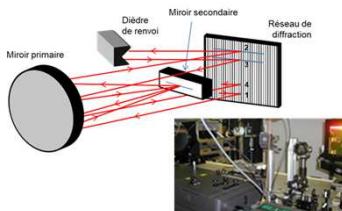
Target integrated coil hold by the cryogenic target inserter (AXIS 4)





A new front-end (AXIS 1+2+3)

- PETAL front-end V1 is based on OPCPA (CPA + ns OPA)



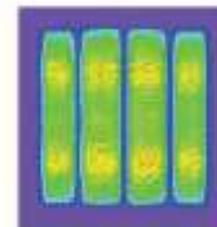
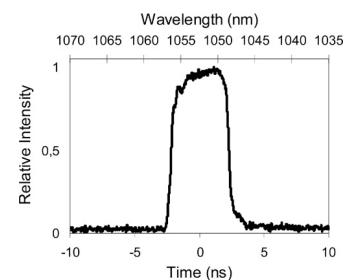
Öffner stretcher



PETAL PAM

*Chirped pulse
8 nm, 4.5 ns
150 mJ
1 shot/3 min.*

E. Hugonnot et al, Appl. Opt., 46, 8181 (2007)



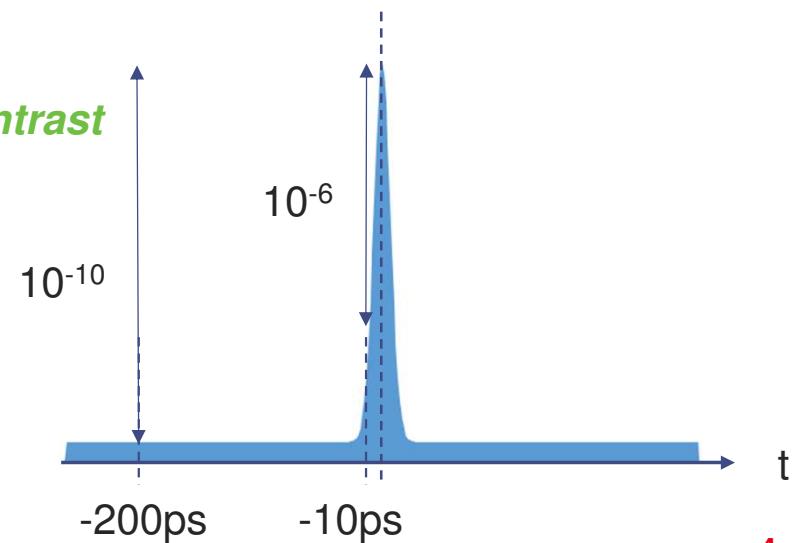
- PETAL front-end V2 will be based on OPCPA (CPA + fast OPA + ns OPA)

Laser specifications

Front-end V1 specs plus

- Contrast requirements: 10^{-10} @-200ps
 10^{-6} @-10ps
- Nanosecond monochromatic pedestal
- 2 Hz repetition rate
- Dispersion management (up to 7 ps/nm)
- Delay lines (up to 16,7 ns)

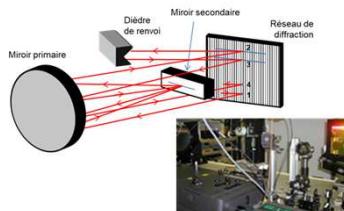
*High temporal contrast
front-end*





A new front-end (AXIS 1+2+3)

- PETAL front-end V1 is based on OPCPA (CPA + ns OPA)



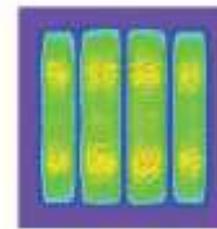
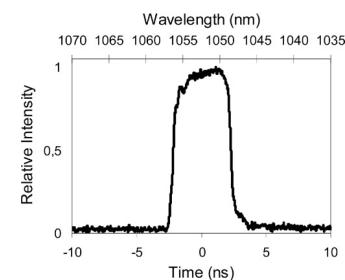
Öffner stretcher



PETAL PAM

150 mJ
8 nm
4.5 ns
1 shot/3 min.

E. Hugonnot et al, *Appl. Opt.*, **46**, 8181 (2007)



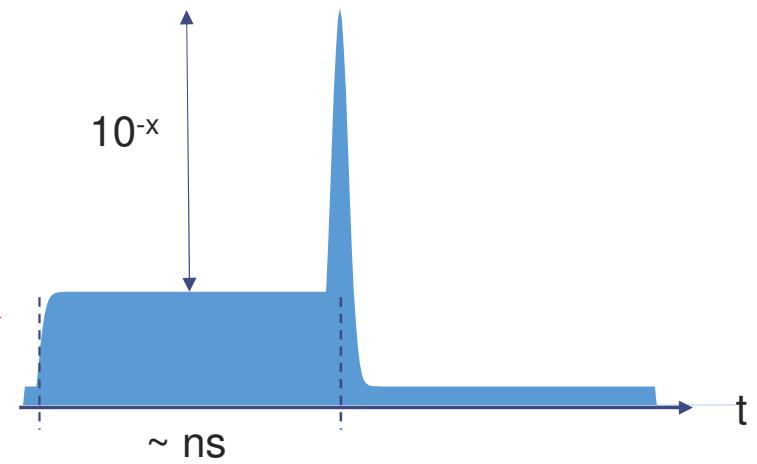
- PETAL front-end V2 will be based on OPCPA (CPA + fast OPA + ns OPA)

Laser specifications

Front-end V1 specs plus

- Contrast requirements: 10^{-10} @-200ps
 10^{-6} @-10ps
- Nanosecond monochromatic pedestal
- 2 Hz repetition rate
- Dispersion management (up to 7 ps/nm)
- Delay lines (up to 16,7 ns)

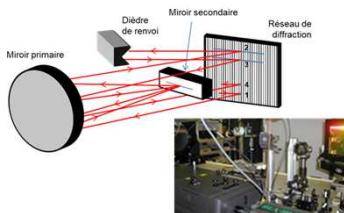
Adjustable contrast





A new front-end (AXIS 1+2+3)

- PETAL front-end V1 is based on OPCPA (CPA + ns OPA)



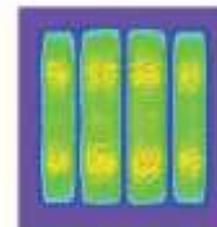
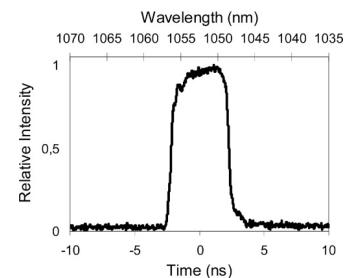
Öffner stretcher



PETAL PAM

150 mJ
8 nm
4.5 ns
1 shot/3 min.

E. Hugonnot et al, *Appl. Opt.*, **46**, 8181 (2007)



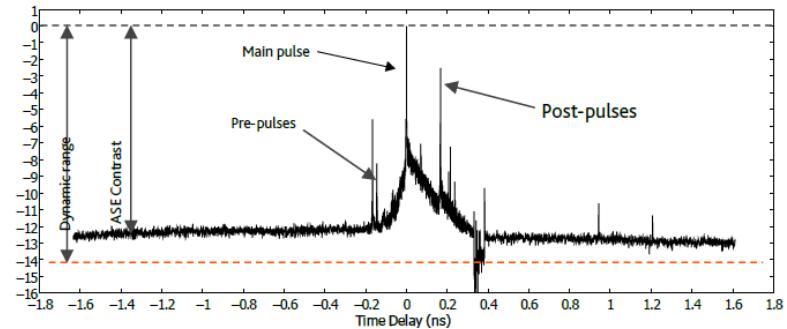
- PETAL front-end V2 will be based on OPCPA (CPA + fast OPA + ns OPA)

Laser specifications

Front-end V1 specs plus

- Contrast requirements: 10^{-10} @-200ps
 10^{-6} @-10ps
- Nanosecond monochromatic pedestal
- **2 Hz repetition rate**
- Dispersion management (up to 7 ps/nm)
- Delay lines ($\Delta t=0$ to 16,7 ns)

will greatly simplify alignment, diagnostics (contrast measurement), ...

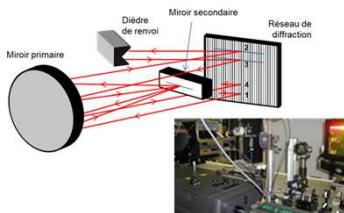


Typical contrast measurement curve with Sequola



A new front-end (AXIS 1+2+3)

- PETAL front-end V1 is based on OPCPA (CPA + ns OPA)



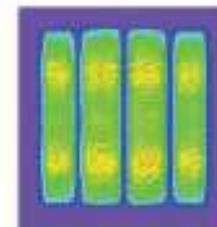
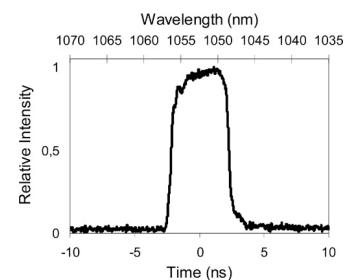
Öffner stretcher



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8 nm
4.5 ns
1 shot/3 min.

E. Hugonnot et al, *Appl. Opt.*, **46**, 8181 (2007)



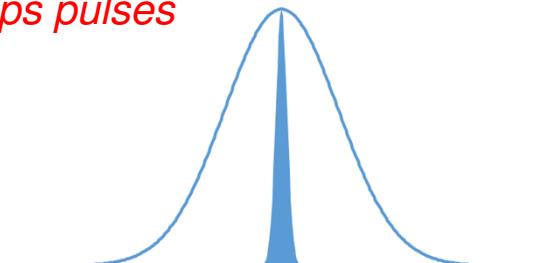
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Laser specifications

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- Contrast requirements: 10^{-10} @-200ps
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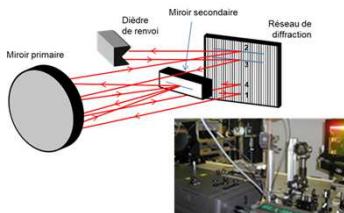
*from Fourier transform pulses (500 fs)
to 20 ps pulses*





A new front-end (AXIS 1+2+3)

- PETAL front-end V1 is based on OPCPA (CPA + ns OPA)



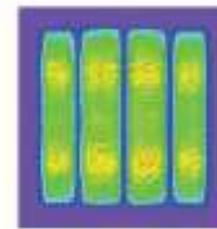
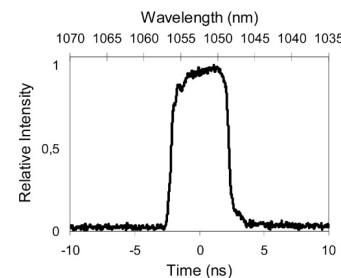
Öffner stretcher



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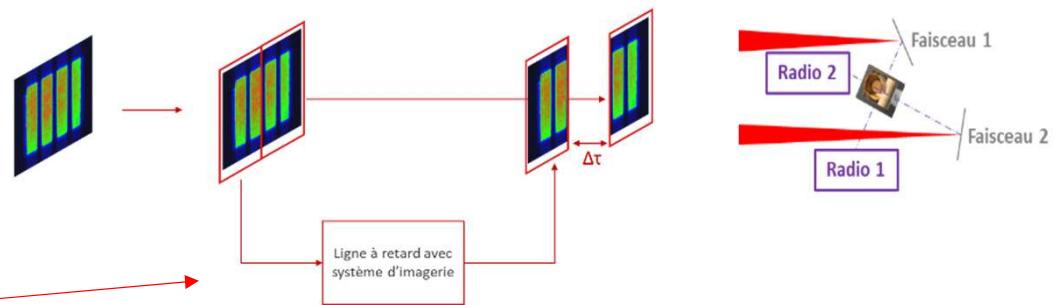


- PETAL front-end V2 will be based on OPCPA (CPA + fast OPA + ns OPA)

Laser specifications

Front-end V1 specs plus

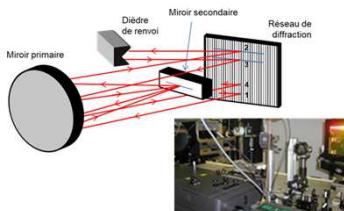
- Contrast requirements: 10^{-10} @-200ps
 10^{-6} @-10ps
- Nanosecond monochromatic pedestal
- 2 Hz repetition rate
- Dispersion management (up to 7 ps/nm)
- Delay lines ($\Delta t=0$ to 16,7 ns)





A new front-end (AXIS 1+2+3)

- PETAL front-end V1 is based on OPCPA (CPA + ns OPA)



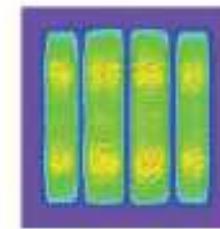
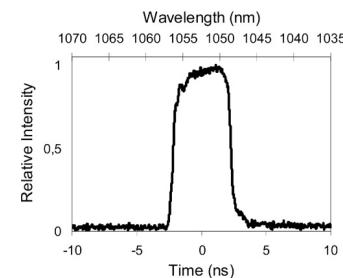
Öffner stretcher



PETAL PAM

150 mJ
8 nm
4.5 ns
1 shot/3 min.

E. Hugonnot et al, *Appl. Opt.*, **46**, 8181 (2007)



- PETAL front-end V2 will be based on OPCPA (CPA + ps OPA + ns OPA)

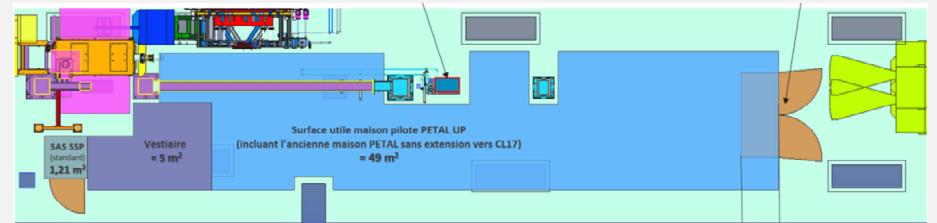
Laser specifications

Front-end V1 specs plus

- Contrast requirements: 10^{-10} @-200ps
 10^{-6} @-10ps
- Nanosecond monochromatic pedestal
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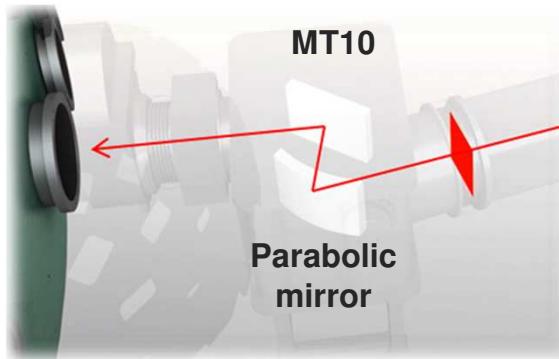
Reliability and easy-to-use requirements

Home-made front-end V1 ⇒ Factory-made front-end V2
The front-end will be deployed in a dedicated lab



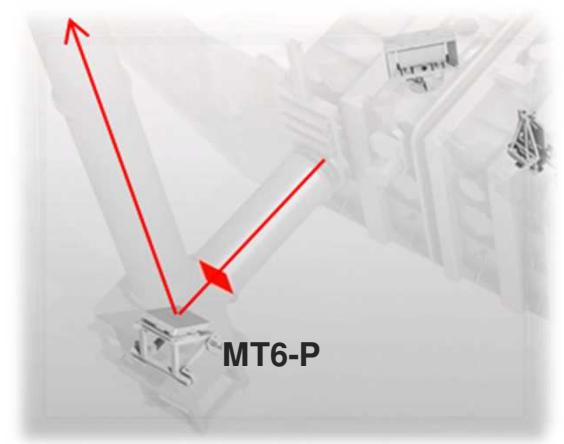
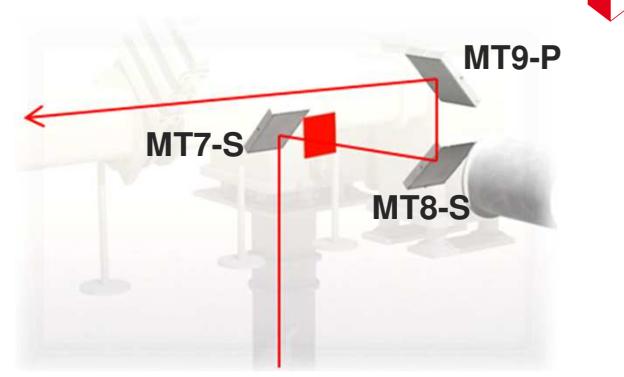
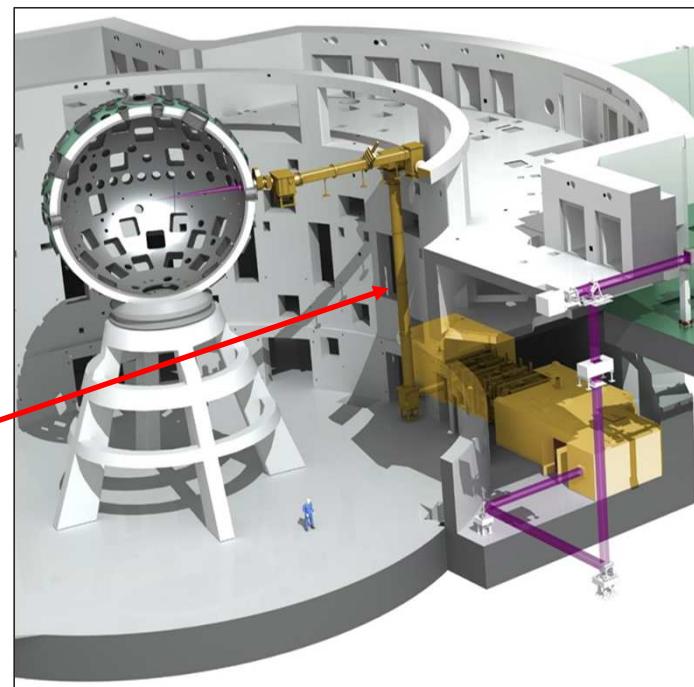
!! Call for tender is underway !!
Laser manufacturer will be chosen before end-2023

New final optics (AXIS 2)



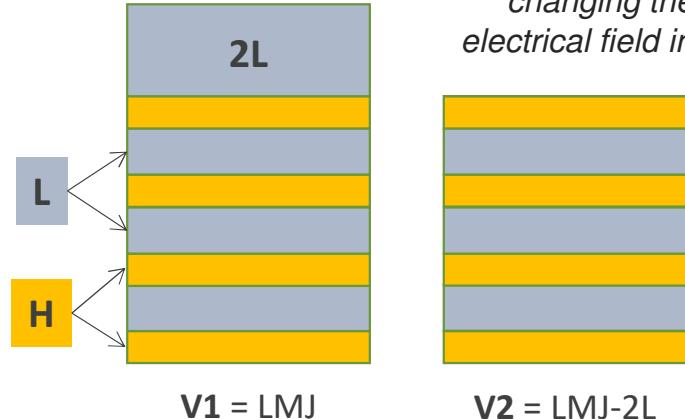
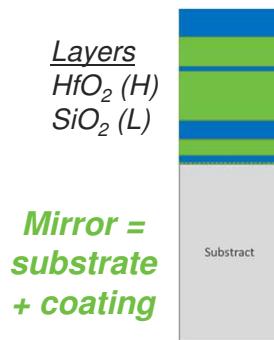
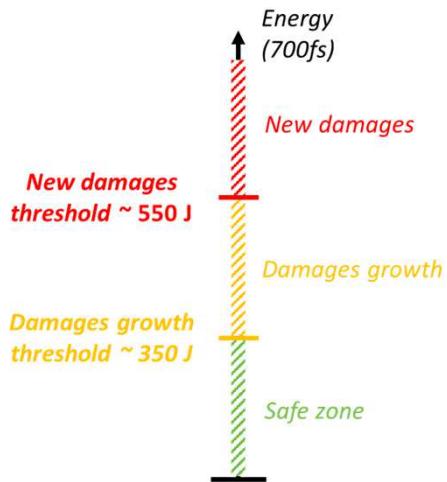
~60 meters after compression (PW range) with 6 mirrors (1 parabolic) and 4 vacuum chambers

*Damages on
MT10 and
parabolic mirror*

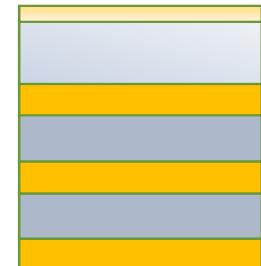




New final optics (AXIS 2)



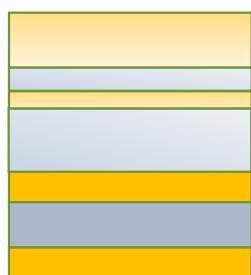
changing the stack design reduces the electrical field in the first layers of the coating



V3

Damages threshold ~ 750 J (± 100 J)

Most recent generation = V4



Design @CEA and processing@LLE

M. Choré et al., SPIE Laser Damage (2021)
S. Diop et al., Optics Letters, 47, 6177 (2022)
S. Diop et al, Applied Optics, 62, B126 (2023)

Experimental damage studies

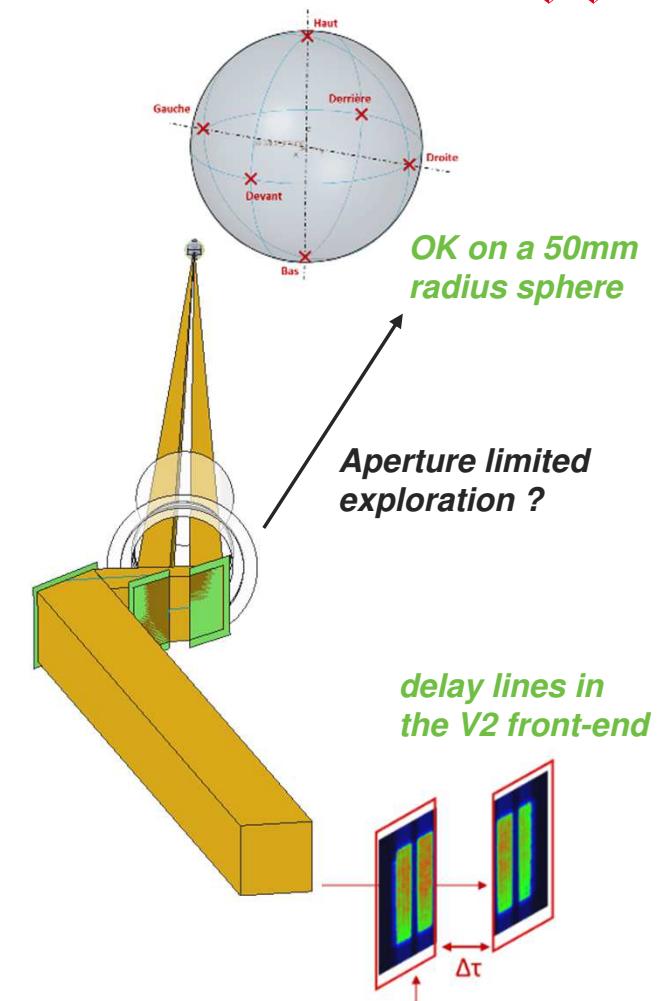
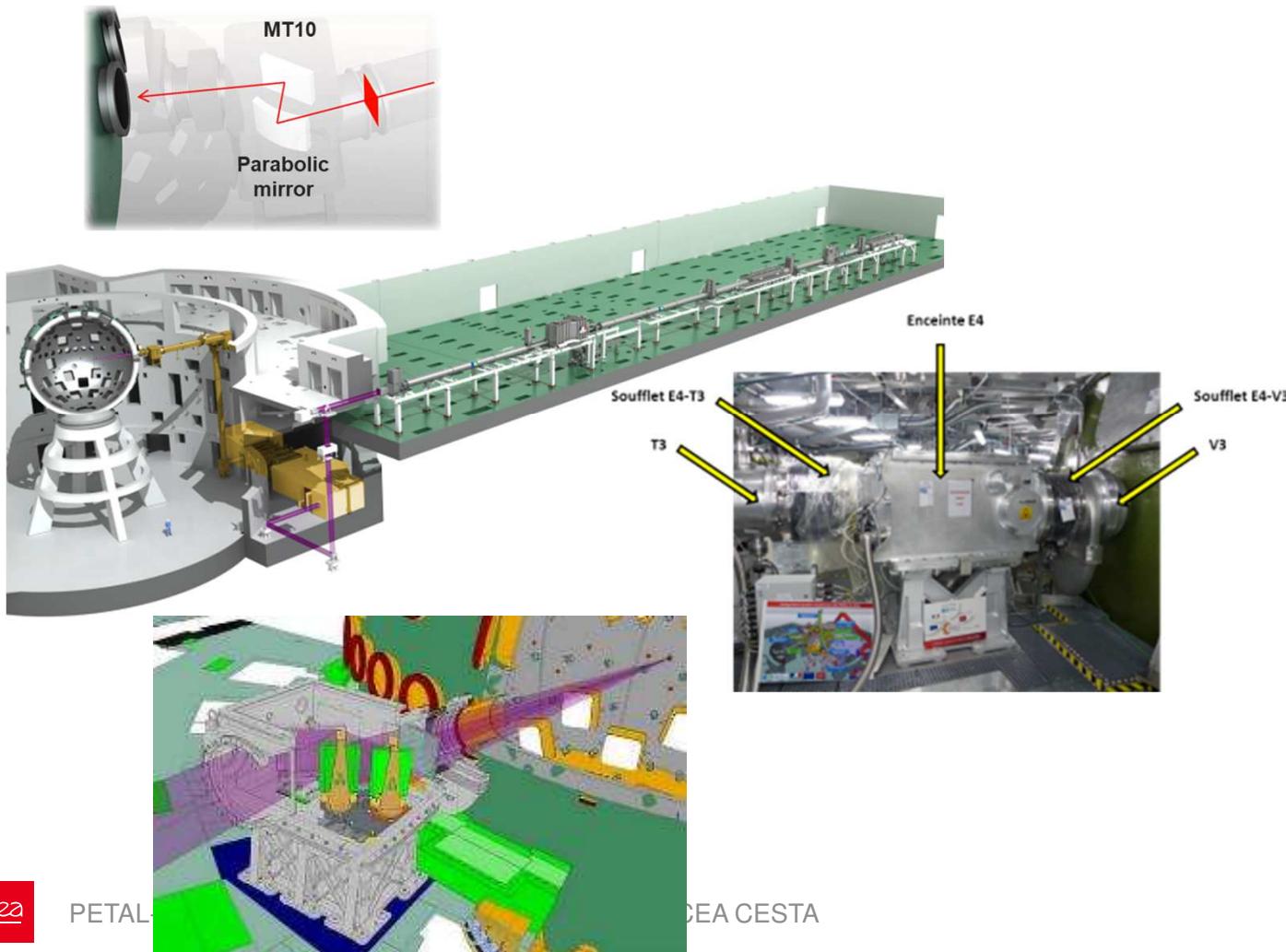
Type de miroir & Polarisation de test	LIDT estimé sous vide [J/cm²]	Réflectivité mesurée à LLE [%]	LIDT mesuré à LLE [J/cm²] (45deg, vide)
Miroir classique V2	P-pol	1.41	99.8%
	S-pol	2.13	100%
Miroir optimisé V4-P	P-pol	2.31	99.2% + 65 %
	S-pol	3.17	99.9% 2.33 +/- 0.033

V4 OK for kJ level

PETAL mirrors will be replaced by V4 generation in the next few years (the first V4 mirror has been realized this year)



Two beams delivery (AXIS 3)





Mirror Segmentation (AXIS 3)

The main challenge is beam phasing (to recover one beam)

Specifications

Angular resolution = 25 nrad

Residual deformation with motion < 70 nm

Optical components

two BK7 mirrors

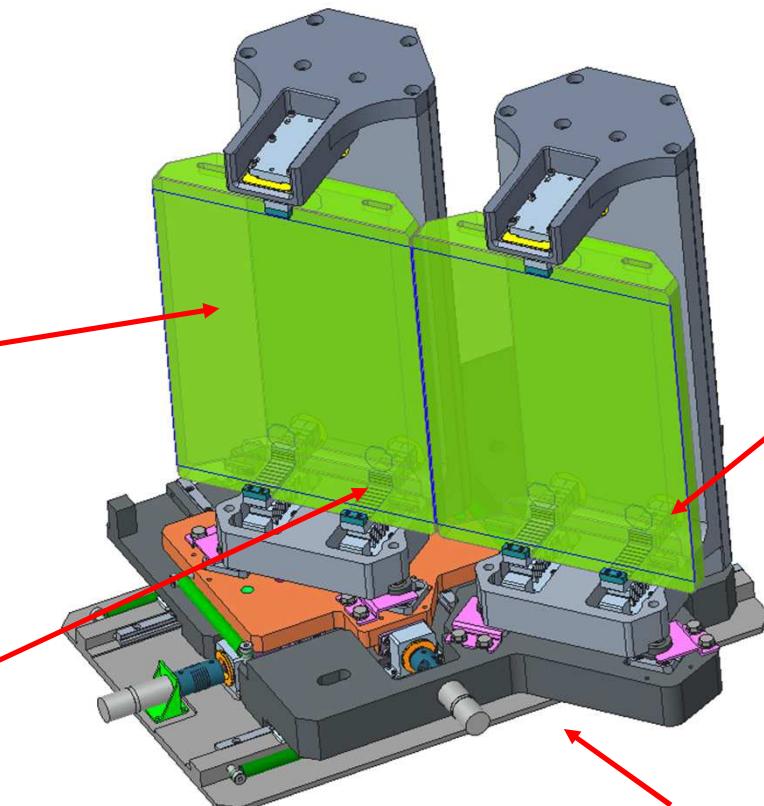
420mmx350mmx80mm

Power: PV< 170nm

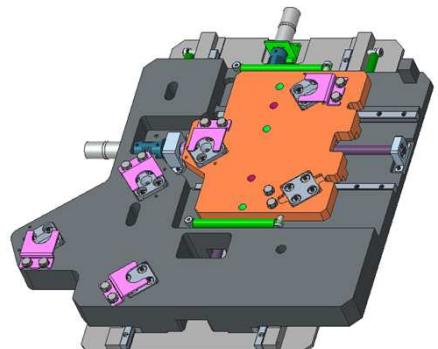
Flatness PV< 160 nm

RMS slope < 1 μ rads

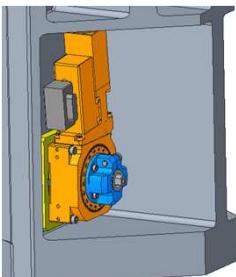
Elastic deformation maintaining systems (will be patented)



2-axis translation table



Fabrication 2nd semester 2023



Actuators

Resolution ~ 1 nm

Motion = \pm 4 mm



B-field capability (AXIS 4)

2022	2023	2024	2025	2026	2027	2028
		Feasibility	Specification	Fabrication	Qualification	Implementation

► Feasibility study phase

→ end expected by late-2024: “GO / NO GO” decision

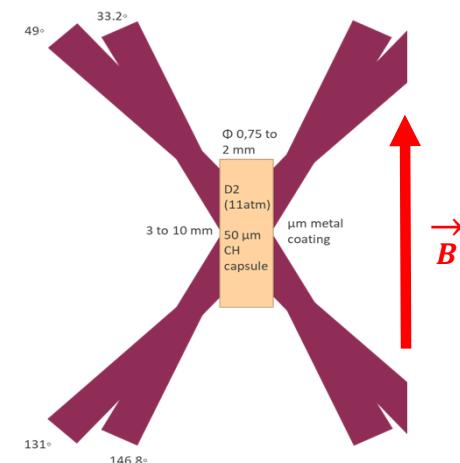
- Sizing of the electromagnetic system
- Performances evaluation
- Identification of the interfaces and preparation for integration
- Evaluation of acquisition and operating costs

► Specifications discussed with CELIA, LULI and CEA/DIF

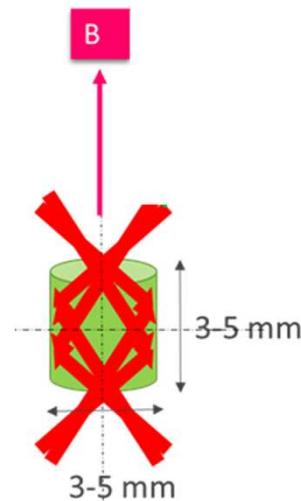
- 30 T on a $\varphi = 6 \text{ mm} \times h = 6 \text{ mm}$ cylindrical volume
- 5-10 % spatial homogeneity
- 100 ns duration
- 5 % temporal stability
- Vertical direction

► Typical experiments for first sizing

*Direct drive fusion
(ex from CELIA)*



Intense X-ray sources





Integration on the cryogenic target inserter (AXIS 4)

► Main choices of concepts

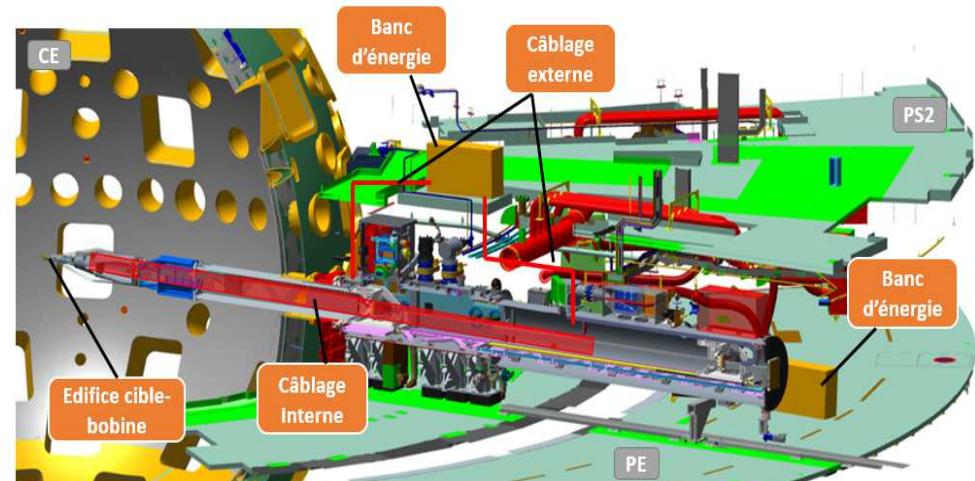
- Target integrated coil held by an inserter
- Integration into the cryogenic positioner PCC (for future cryogenic compatibility)
- Pulser in the experiment room (the options into the inserter are too complex for maintenance, integration with the cryogenic inserter)
- Non destructive coil (mainly because of the risks of incomplete vaporization with destructive coil)

► Integration on the cryogenic target positioner (PCC)

- Mutualizes the needs
- 2 phases of employment envisaged
 - separate DT cryogenic / magnetic field experiments
 - with cryogeny and B-field together

PCC integration studies have been done

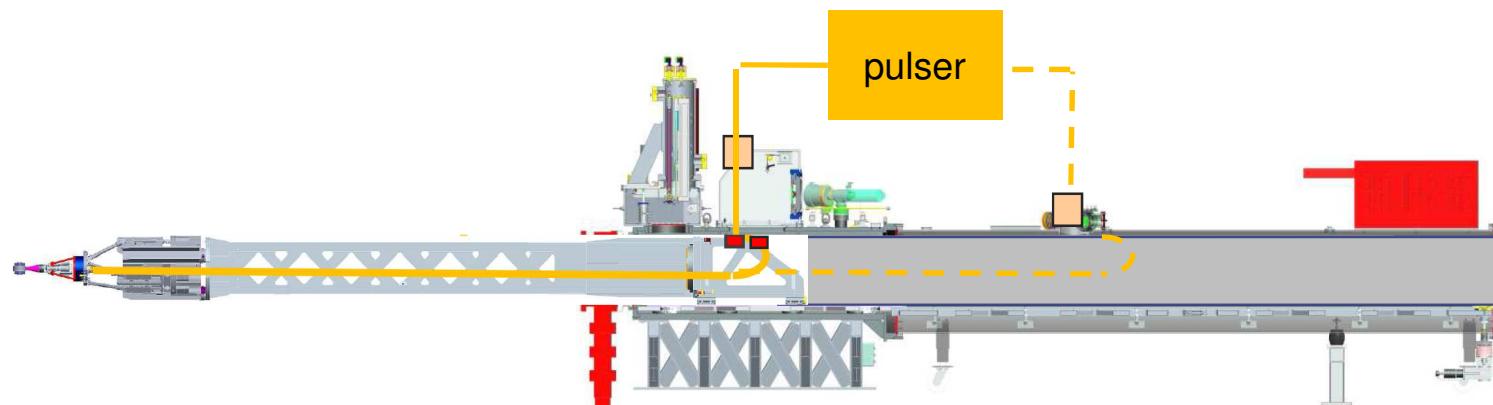
→ feasibility now demonstrated





Engineering issues and associated prototypes (AXIS 4)

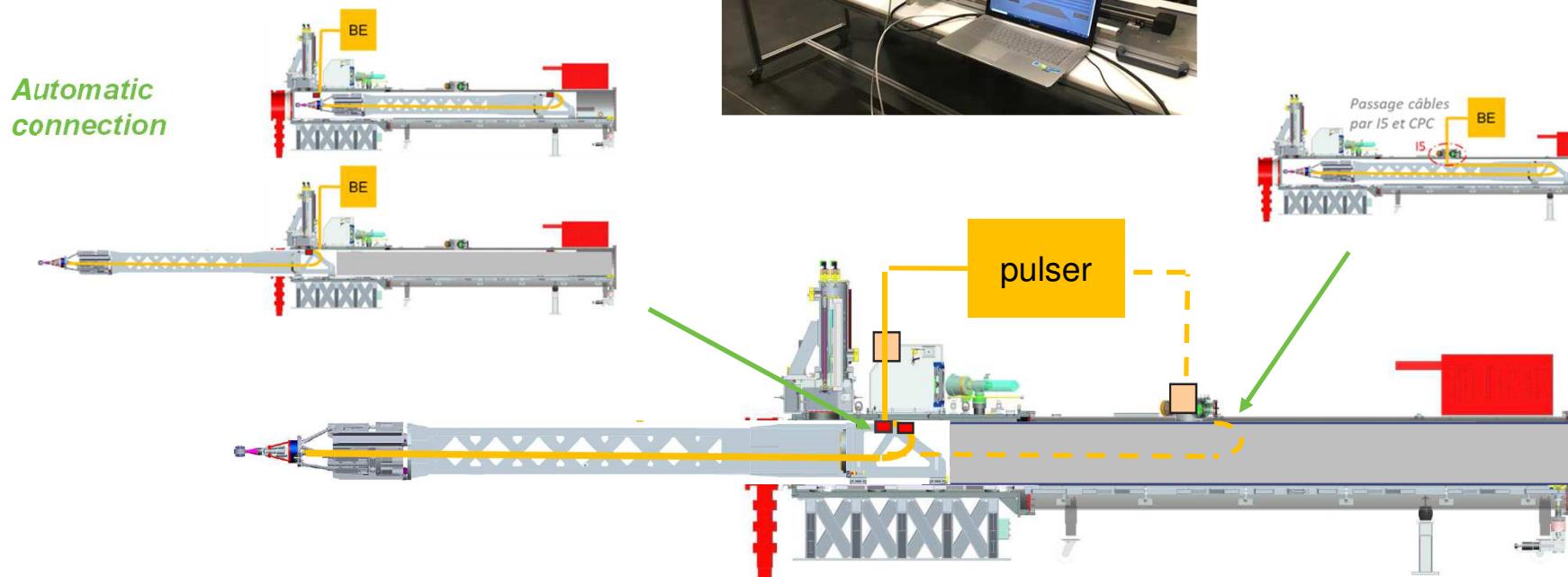
- Some problems still need to be solved ...



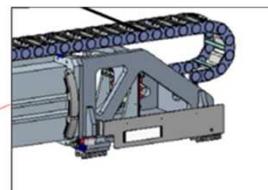


Engineering issues and associated prototypes (AXIS 4)

- Automatic connection or cable track ?



Cable track
mechanical
test bench

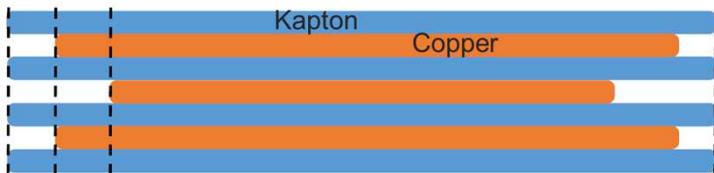


cable-track



Engineering issues and associated prototypes (AXIS 4)

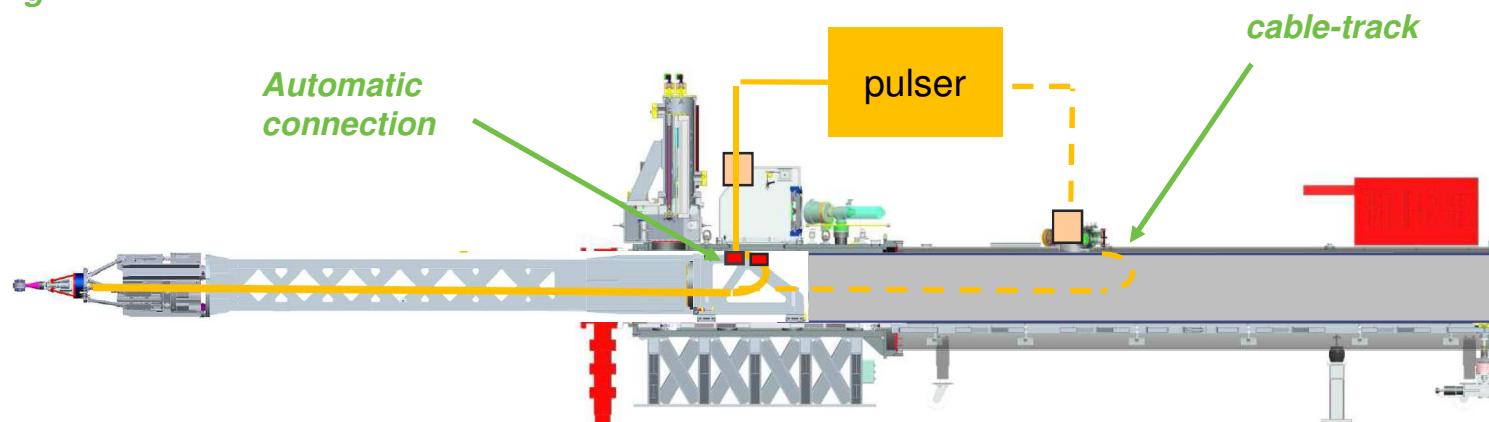
- Standard cables and/or strip-line ?



Benchmark and qualification of a first strip-line
Studies are on-going



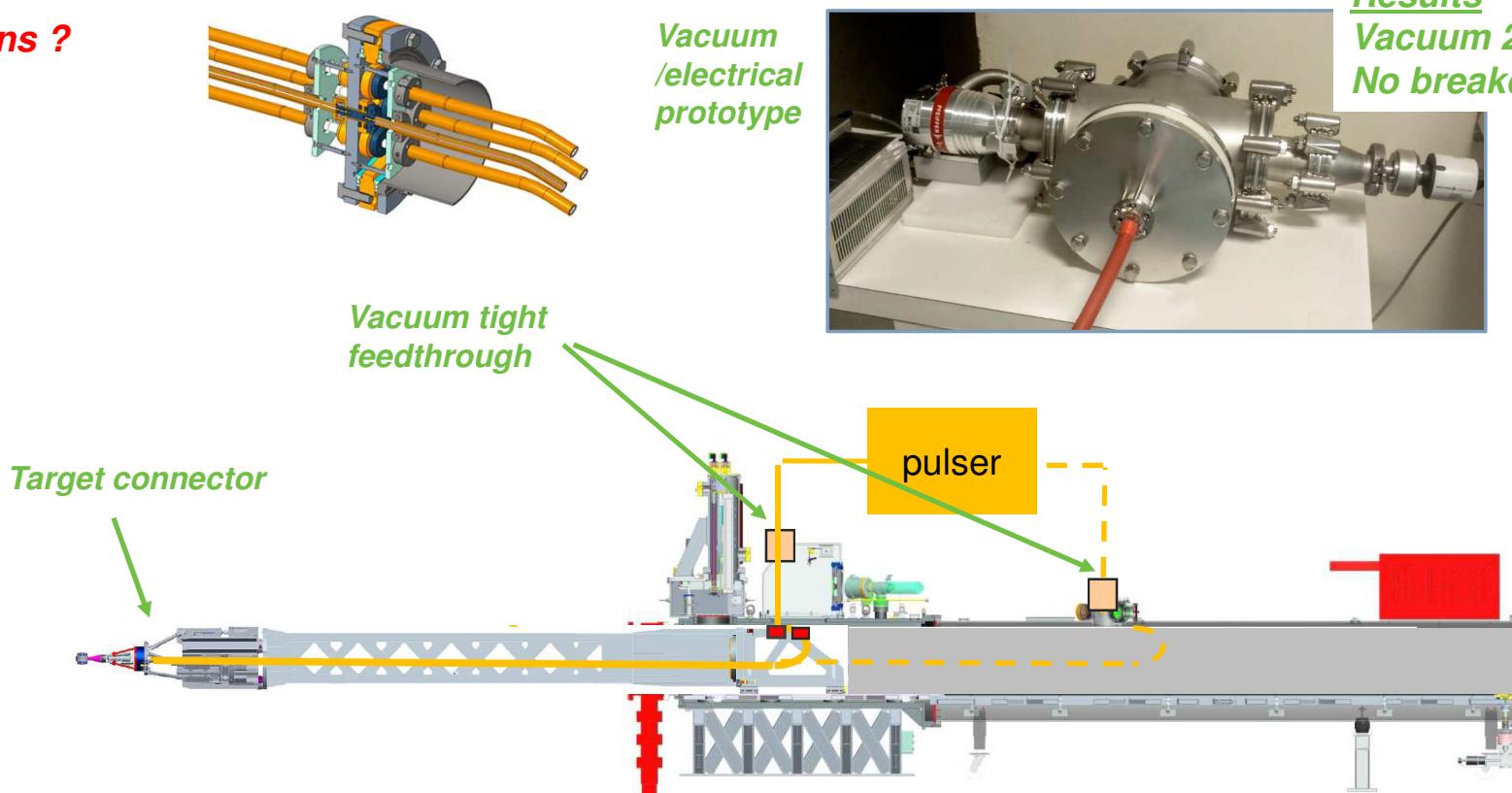
Cable track
mechanical
test bench





Engineering issues and associated prototypes (AXIS 4)

- Connections ?



Vacuum /electrical prototype



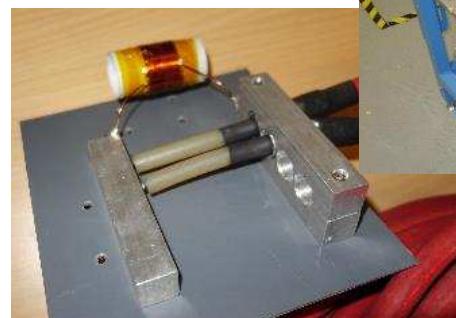
Results

Vacuum $2 \cdot 10^{-6}$ mbar
No breakdown up to 35 kV

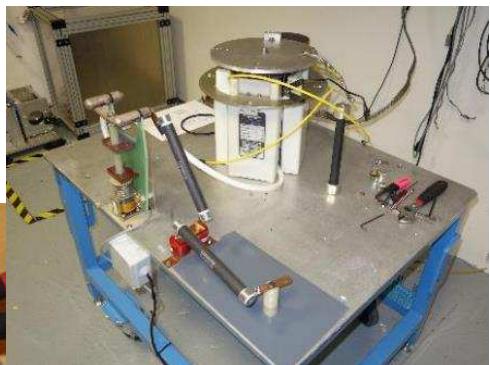


Engineering issues and associated prototypes (AXIS 4)

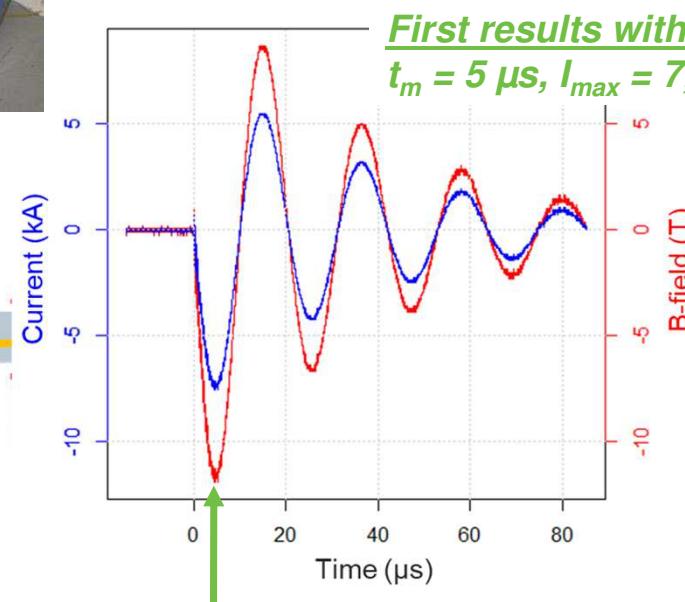
- **B-field performances ?**
- **Debris risks ?**
- **Remote effects ?**



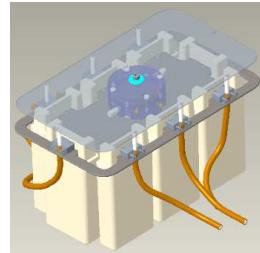
B field performances
Debris risks
Remote effects



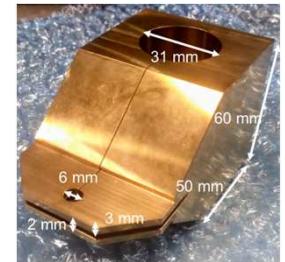
**Electro-tech.
prototype**



**Laser shot will
happen here**



**New 2 kJ pulser
under construction**



**Target-coil
prototype to
be tested**



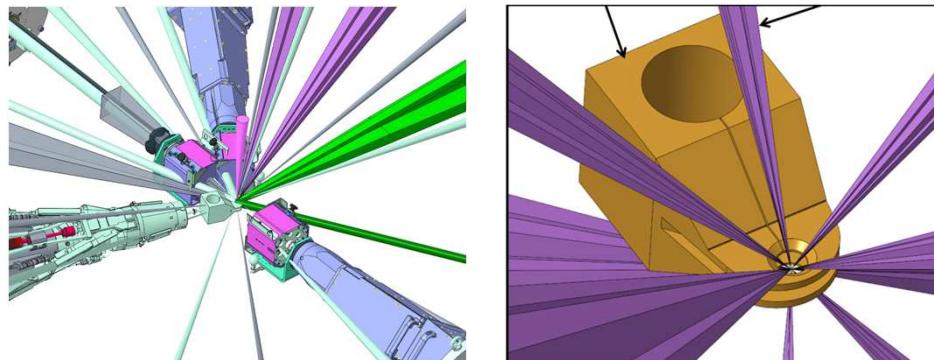
**Home-made
coil**



Engineering issues and associated prototypes (AXIS 4)

- Alignment ?
- Shocks ?

Integration / alignment studies are on-going

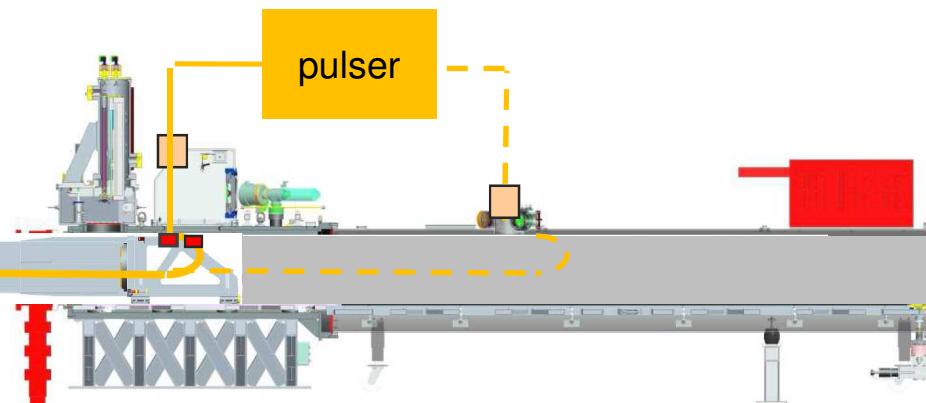


Debris risks Alignment

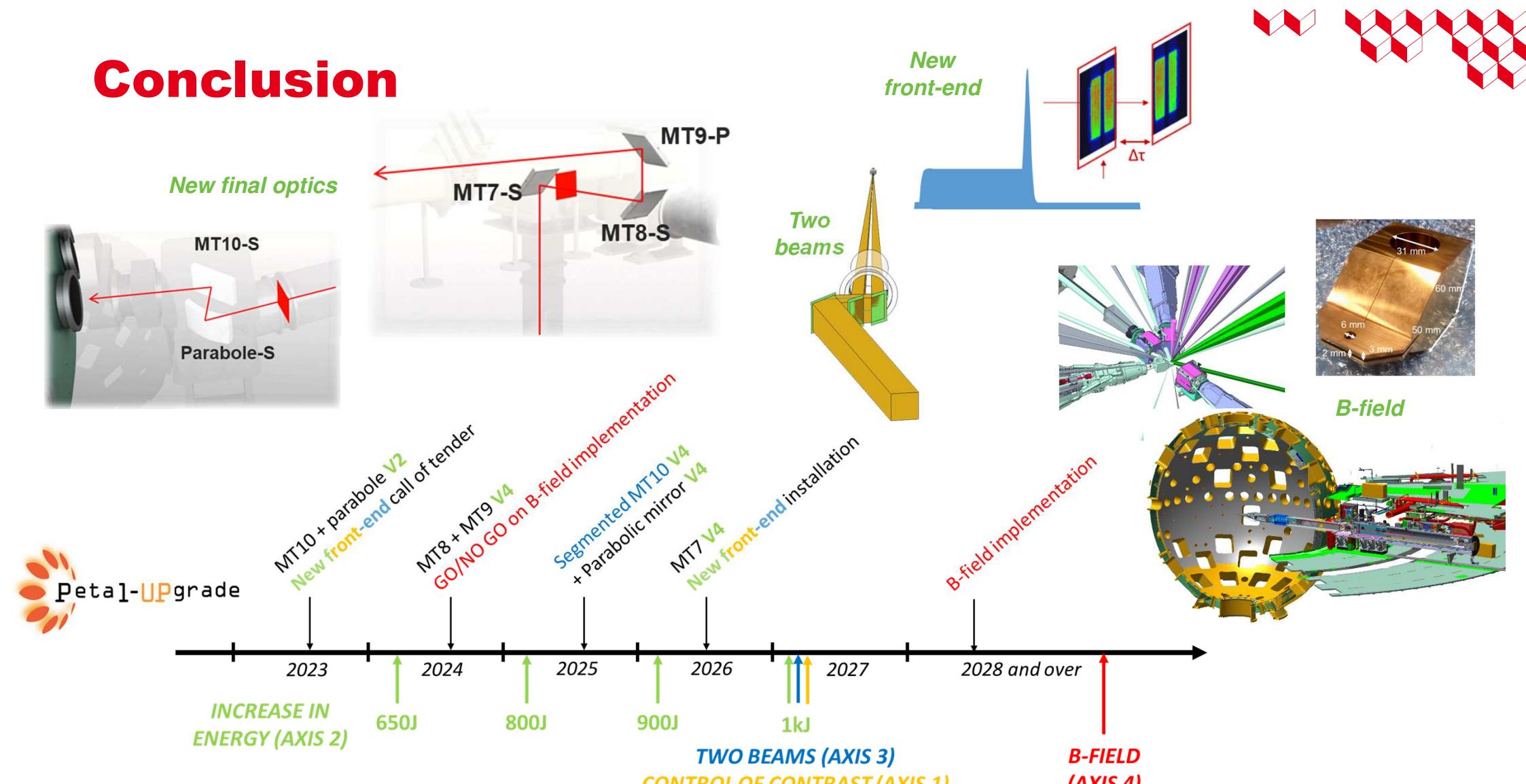
Laser thermo-shock

Numerical simulations in progress

Transmitted shock



Conclusion





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